

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: BILL H QUON, WAYNE L JOHNSON

Application No.:

Confirmation

No:

Filed: December 23, 2003

Group No.: 9999

Examiner

For: INTER-STAGE PLASMA SOURCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

APPLICATION DATA SHEET
37 C.F.R. § 1.76

BIBLIOGRAPHIC DATA

1. Applicant information

First applicant: BILL H QUON

Citizenship: USA

Residence: Brea, CA 92821

Second applicant: WAYNE L JOHNSON

Citizenship: USA

Residence: Phoenix, AZ 85044

2. Correspondence information

Correspondence for this application should be addressed as follows:

Customer No.: 00909

3. Application information

Title of Invention: INTER-STAGE PLASMA SOURCE

Docket number assigned to this application: 071469-0306171

Suggested Classification: Class:

Subclass:

Technology Center to which subject matter is assigned:

Total number of drawing sheets: 7

Type of application: Utility

Application is to be published. Suggested drawing figure for publication:

Secrecy order under § 5.2:

This application does not disclose subject matter of an application which is under a secrecy order pursuant to § 5.2.

4. Representative information

The following have a power of attorney or authorization of agent in this application:

Customer No.: 00909

5. Domestic Priority information

Domestic priority for this application is claimed as follows:

35 U.S.C. § 120:

Application No.: PCT/US02/20868

Filed: July 2, 2002

Status: pending

Relationship: parent

Application No.: 60/302,361

Filed: July 3, 2001

Status: abandoned

Relationship: priority

6. Assignee information

The assignee(s) of this application is/are:

Tokyo Electron Limited

2-6, Akasaka 5-chome, Minato-ku

Tokyo, 107

JAPAN

Extent of interest of assignee in application: 100%

Date: December 23, 2003

PILLSBURY WINTHROP LLP

P.O. Box 10500

McLean, VA 22102

Customer No. 00909



Signature of Practitioner

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